



**ELECTRONIC COPY**

LG636417121  
Report verification at [igi.org](http://igi.org)

**LABORATORY GROWN DIAMOND REPORT**

June 1, 2024  
IGI Report Number **LG636417121**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **9.02 X 6.27 X 4.30 MM**

**GRADING RESULTS**

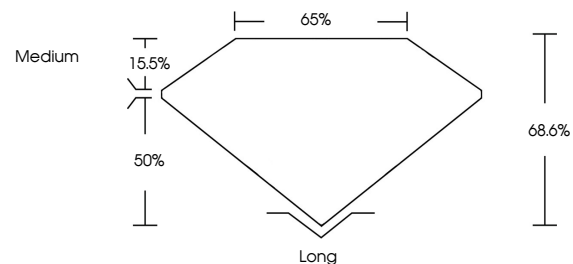
Carat Weight **2.37 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG636417121**

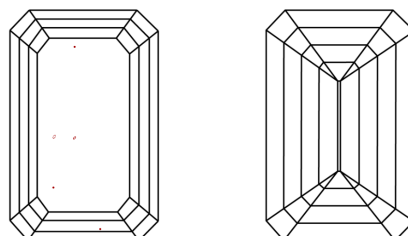
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

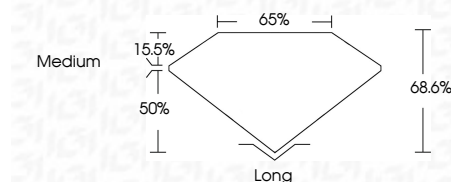
D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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June 1, 2024  
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**EMERALD CUT**  
9.02 X 6.27 X 4.30 MM  
Carat Weight **2.37 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**  
Depth **68.6%**  
Table **65%**  
Girdle **Medium**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG636417121**

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